



In re the Application of: HIRASE, Masaki et al.

Group Art Unit: 2812

Serial No.: 09/908,941

Examiner: KENNEDY, Jennifer M.

Filed: July 20, 2001

P.T.O. Confirmation No.: 1043

FOR: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE

**SAME** 

INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(c)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 14, 2004

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

This Information Disclosure Statement is being submitted after issuance of a first official action on the merits and expiration of the three month period following the filing date or the entry of the national stage for the above-captioned application, but prior to issuance of either a final official action or a Notice of Allowance.

The undersigned hereby certifies that each item of information contained in this statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that

the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this statement to our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP

Buch of

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PATENT TRADEMARK OFFICE

Enclosures:

Office Action received in corresponding Japanese patent application

PTO-1449 References (3) PE 16 2004 25

PE 16 2004 25

PRADENT FORMATION
DISCLOSURE
CITATION
PTO-1449

Atty. Docket No. 010917

Serial No. 09/908,941

Applicant(s): HIRASE, Masaki et al.

Filing Date: July 20, 2001

Group Art Unit: 2812

## **U.S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						
	AC						i i
·	AD						
	AE						

## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
	AF	11-135404	5/21/99	Japan	Abstract only
·	AG	2001-338974	12/07/01	Japan	Abstract only
	AH	2001-52993	2/23/01	Japan	Abstract only
	ΑI				
	AJ				

## OTHER DOCUMENTS

	AK	
	AL	
Examiner		Date Considered